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| <b>Notice of References Cited</b> |  | Application/Control No. | Applicant(s)/Patent Under Reexamination |             |
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| ADAM A. ARCIERO                   |  |                         |   |             |

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|   | A | US-  |                 |      |                |
|   | B | US-  |                 |      |                |
|   | C | US-  |                 |      |                |
|   | D | US-  |                 |      |                |
|   | E | US-  |                 |      |                |
|   | F | US-  |                 |      |                |
|   | G | US-  |                 |      |                |
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|   | M | US-  |                 |      |                |

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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